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ZIJP et al.

**GROUP**

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## U.S. PATENT DOCUMENTS

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## FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS						TRANSLATION	
DOCUMENT		DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
	2000-252500	9/2000	Japan			ABSTRACT	
	62-179165	8/1987	Japan			ABSTRACT	
	59-094472	5/1984	Japan			ABSTRACT	
	60147176	1/1984	Japan			ABSTRACT	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

	Tominaga et al., "Transparent conductive ZnO film preparation by alternating ...", Thin Solid Films, Elsevier-Sequoia S.A., 334 (1998) 35-39; XP004157844.
	Romeo et al., "A highly efficient and stable CdTe/CdS ...", Solar Energy Materials & Solar Cells, Elsevier Science Publishers, 58 (1999) 209-218; XP004177956.
	Romeo et al., "Comparison of different conducting oxides as substrates ...", Thin Solid Films, Elsevier Sequoia, 431-432 (2003) 364-368; XP004428668.

\*Examiner

/Khanh Nguyen/

Date Considered

03/13/2008

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Initial this form with next communication to application.